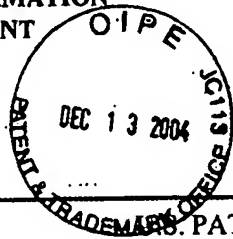


FORM PTO - 1449

SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT

ATTY DOCKET NO.: ASC-23DVC2

APPLICANT(S): Fitzgerald

SERIAL NO.: 10/022,689

FILING DATE: December 17, 2001

GROUP: 2813

PATENT DOCUMENTS

| EXAM. INIT. | | DOCUMENT NUMBER | DATE | NAME | CLASS | SUB CLASS | FILING DATE IF APPROPRIATE |
|----------------|------|--------------------|------------|-------------------------|-------|--------------|-------------------------------|
| <i>RL</i> | A121 | 4,969,031 | 11/06/1990 | Kobayashi <i>et al.</i> | | | |
| <i>RL</i> | A122 | 5,240,876 | 08/31/1993 | Gaul <i>et al.</i> | | | |
| <i>RL</i> | A123 | 5,548,128 | 08/20/1996 | Soref <i>et al.</i> | | | |
| <i>RL</i> | A124 | 5,572,043 | 11/05/1996 | Shimizu <i>et al.</i> | | | |
| <i>RL</i> | A125 | 5,607,876 | 03/04/1997 | Biegelsen <i>et al.</i> | | | |
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| <i>RL</i> | A130 | 6,646,322 | 11/11/2003 | Fitzgerald | | | 07/16/2001 |
| <i>RL</i> | A131 | 6,677,192 | 01/13/2004 | Fitzgerald | | | 07/16/2001 |
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| EXAM. INIT. | | DOCUMENT NUMBER | DATE | COUNTRY CODE | CLASS | SUB CLASS | FILING DATE | ABSTRACT ONLY | ENGLISH LANG (Y/N) |
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| <i>RL</i> | B40 | 61-141116 | 06/28/1986 | JP | | | | | Y (abstract only) |
| <i>RL</i> | B41 | 2-210816 | 08/22/1990 | JP | | | | | Y (abstract only) |
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| | | | | | | | | | |

OTHER ART, JOURNAL ARTICLES

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| <i>RL</i> | C95 | Godbey <i>et al.</i> , (1990) "Fabrication of Bond and Etch-Back Silicon Insulator Using a Strained $\text{Si}_{0.7}\text{Ge}_{0.3}$ Layer as an Etch Stop," <i>Journal of the Electrical Society</i> , Vol. 137, No. 10 (October 1990) pp. 3219-3223. | | | | | | | |
| <i>RL</i> | C96 | Grillot <i>et al.</i> , "Acceptor diffusion and segregation in $(\text{Al}_x\text{Ga}_{1-x})_{0.5}\text{In}_{0.5}\text{P}$ heterostructures," <i>Journal of Applied Physics</i> , Vol. 91, No. 8 (2002), pp. 4891-4899. | | | | | | | |

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Wesley Schuyler

DATE CONSIDERED

3/3/05

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| | C97 | Halsall <i>et al.</i> , "Electron diffraction and Raman studies of the effect of substrate misorientation on ordering in the AlGaInP system," <u>Journal of Applied Physics</u> , Vol. 85, No. 1 (1999), pp. 199-202. |
| | C98 | Hsu <i>et al.</i> , "Surface morphology of related Ge _x Si _{1-x} films," <u>Appl. Phys. Lett.</u> , Vol. 61, No. 11 (1992), pp. 1293-1295 |
| | C99 | Huang <i>et al.</i> , (2001) "Carrier Mobility enhancement in strained Si-on-insulator fabricated by wafer bonding", <u>2001 Symposium on VLSI Technology, Digest of Technical Papers</u> , pages 57-58 |
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